IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani

Art Unit : 1765

Serial No.: 09/596,755

Examiner : Robert Kunemund

Filed

: June 15, 2000

Title

: MANUFACTURING METHOD OF SEMICONDUCTOR AND

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information

Disclosure Statement and documents listed on form PTO-1449.

This filing is being made after receipt of a first Office action on the merits. The fee under 37 CFR 1.17(p) is enclosed.

Please note that Document AA is the English-language equivalent of Documents AI-AL. Document AB is the English-language equivalent of Document AM.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left of lumn per MPRF all are earnestly solicited along with an early action on the merits.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

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Respectfully submitted,

Date: 7 1 0 8

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Substrute Form PTO-1449
U.S. Department of Commerce Patent and Trademark Office

Operation Disclosure Statement
by Applicant
Use several sheets if necessary)

Attorney's Docket No.
Operation No.
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U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
36	AA	5,840,118	11/24/98	S. Yamazaki	117	103	
	AB						
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	Foreign Patent Documents or Published Foreign Patent Applications							
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Other Documents (include Author, Title, Date, and Place of Publication)					
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Date Considered

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Notice of References Cited

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Applicant(s)

Hisashi Ohtani

Examiner

James Park

Group Art Unit 2822

Page 1 of 1

11 5	PATENT	DOCUMENTS	

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NON-PATENT DOCUMENTS

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